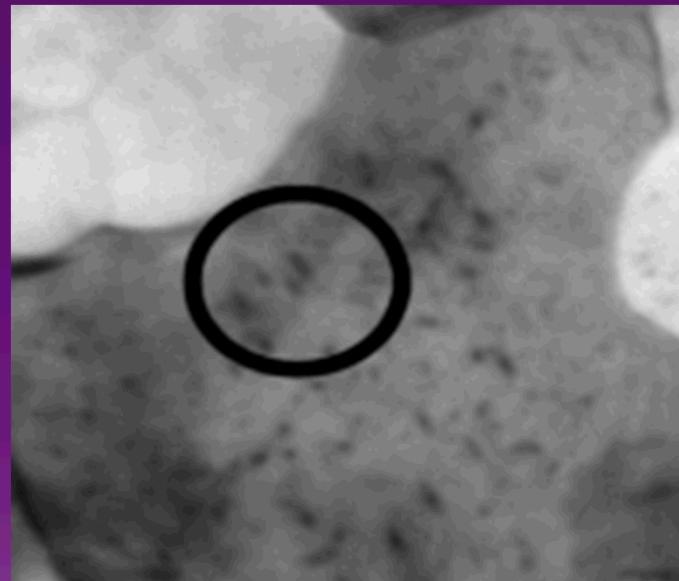
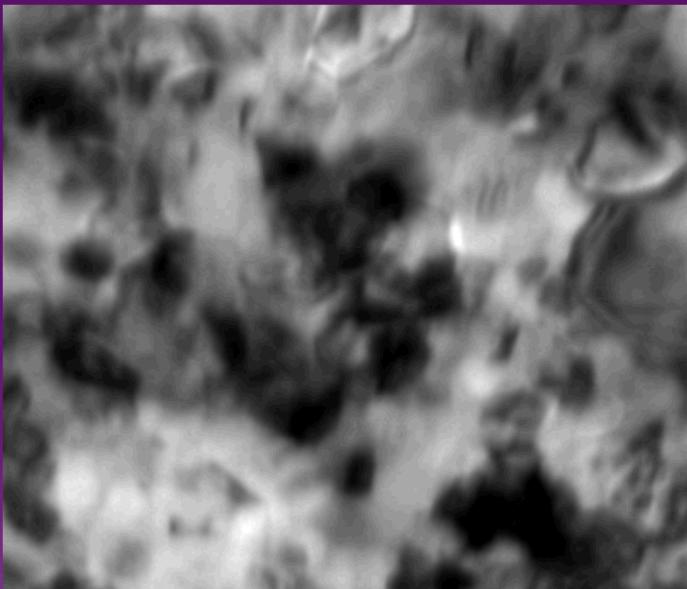


In-Situ He⁺ Implantation and Thermal Aging of Nanocrystalline Iron

SAND2015-6215C

Brittany Muntifering, Sarah Blair, Youwu Fang, Aaron Dunn,
Remi Dingreville, Jianmin Qu, Khalid Hattar



NORTHWESTERN
UNIVERSITY



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Sandia's I³TEM Facility

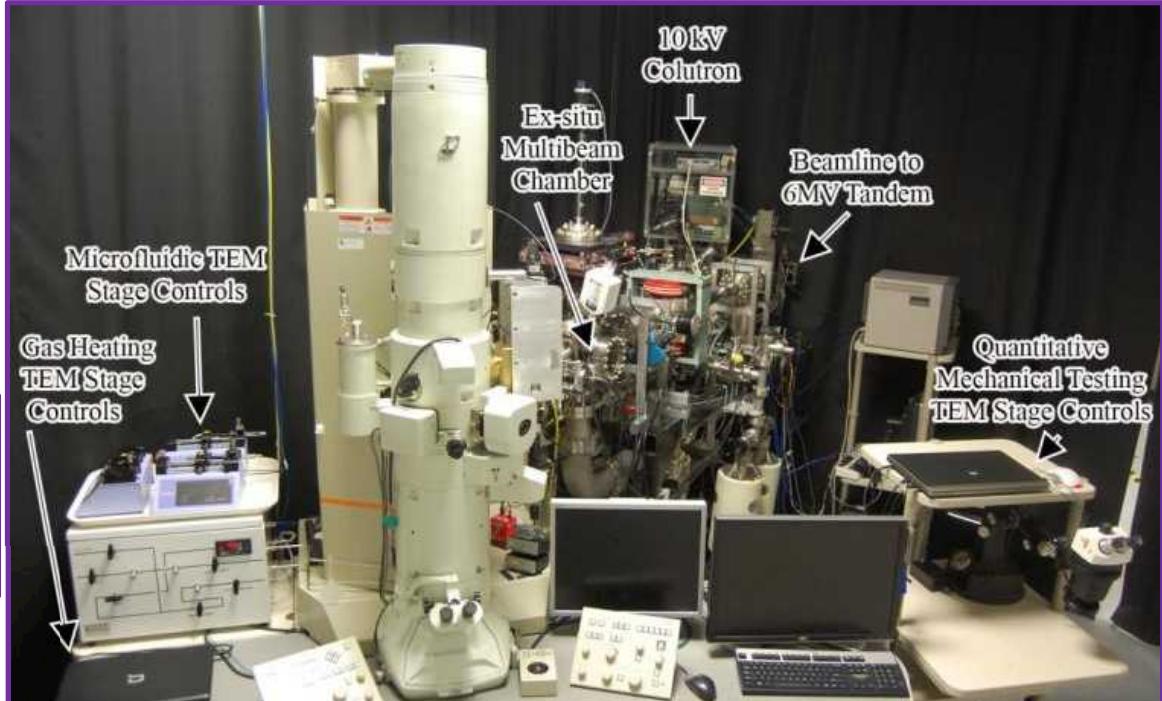
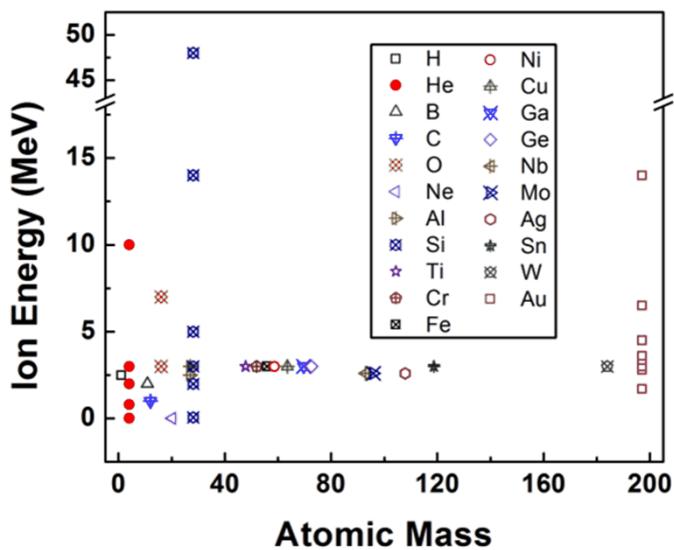


6 MV Tandem



10 kV Colutron

Heavy Ion Irradiation + Gaseous Implantation
Control ratio of dpa and gas species
implantation and characterize coupling effects

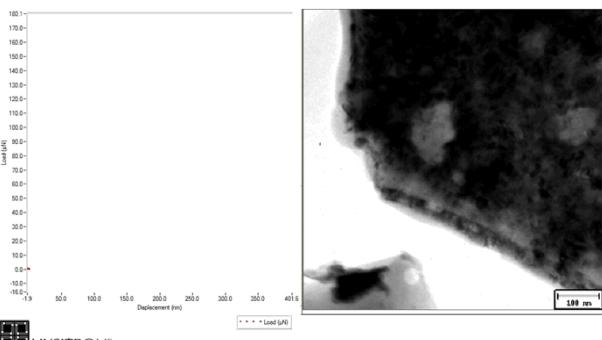


200 kV JEOL 2100 TEM

Direct real time observation of ion irradiation, ion implantation, or both with nanometer resolution

Radiation & Synergistic In- Situ Capabilities

Mechanical Effects



Hysitron PI95 TEM Picoindenter

Gatan 654 Straining Holder

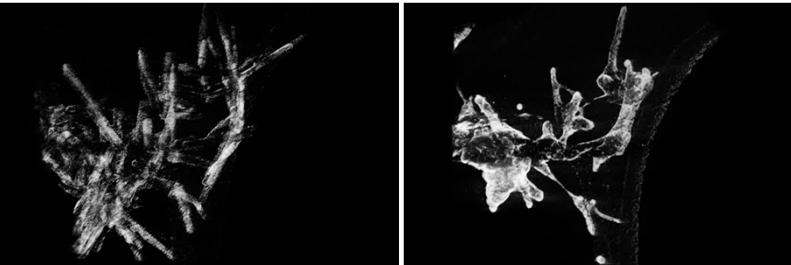
Allows for direct correlation of dose and defect density with resulting changes in strength, ductility, and defect mobility

Structural Effects

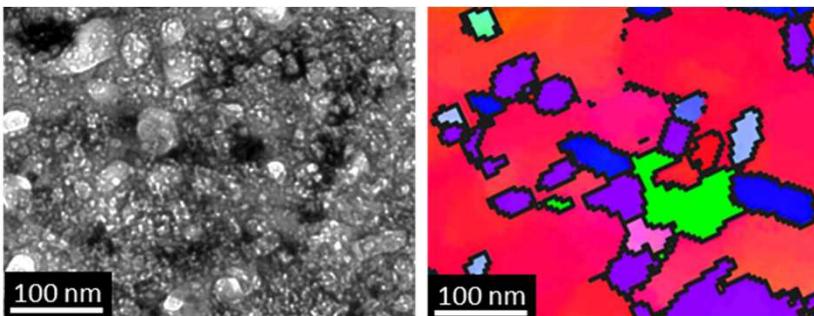
Hummingbird Tomography Stage

Gatan 925 Double Tilt Rotate

Morphology changes as a result of radiation damage



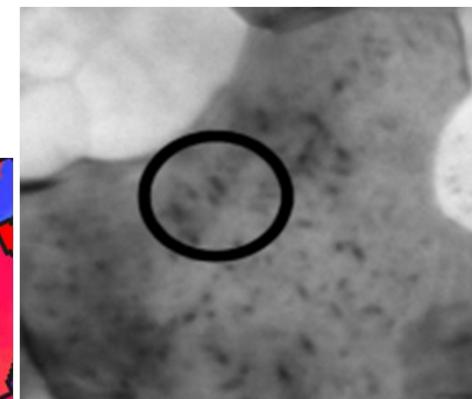
Nanomegas ASTAR
Grain structure changes as a result of radiation and implantation



Thermal Effects

Hummingbird Heating Stage

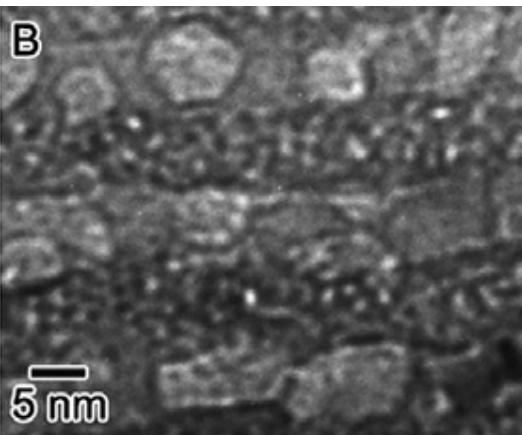
Coupling effects of temperature and irradiation on microstructural evolution up to 800°C



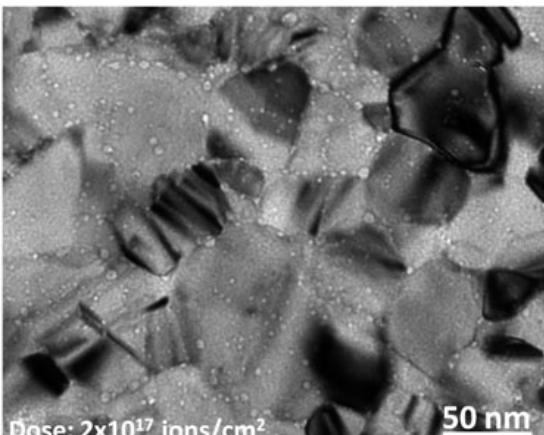
The application of advanced microscopy techniques to characterize synergistic effects in a variety of extreme environments

Helium Interaction with Boundaries and Interfaces

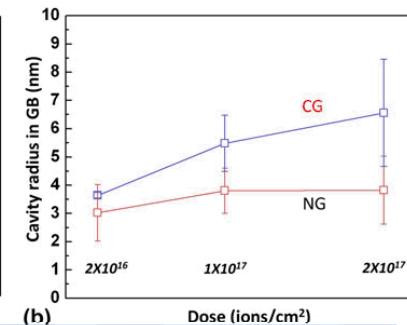
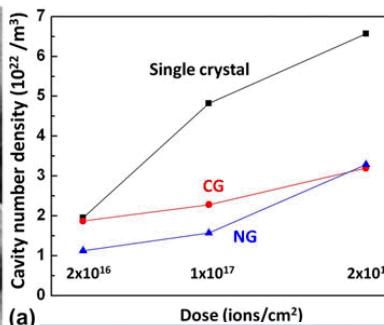
Helium effects embrittlement, void swelling, creep rupture, etc.



K. Hattar, et al. Arrest of He bubble growth in Cu-Nb multilayer nanocomposites. Scripta Materialia (2008)



Weizhong Hana, et al. Irradiation damage of single crystal, coarse-grained, and nanograined copper under helium bombardment at 450 °C. J. Mater. Res. 2013

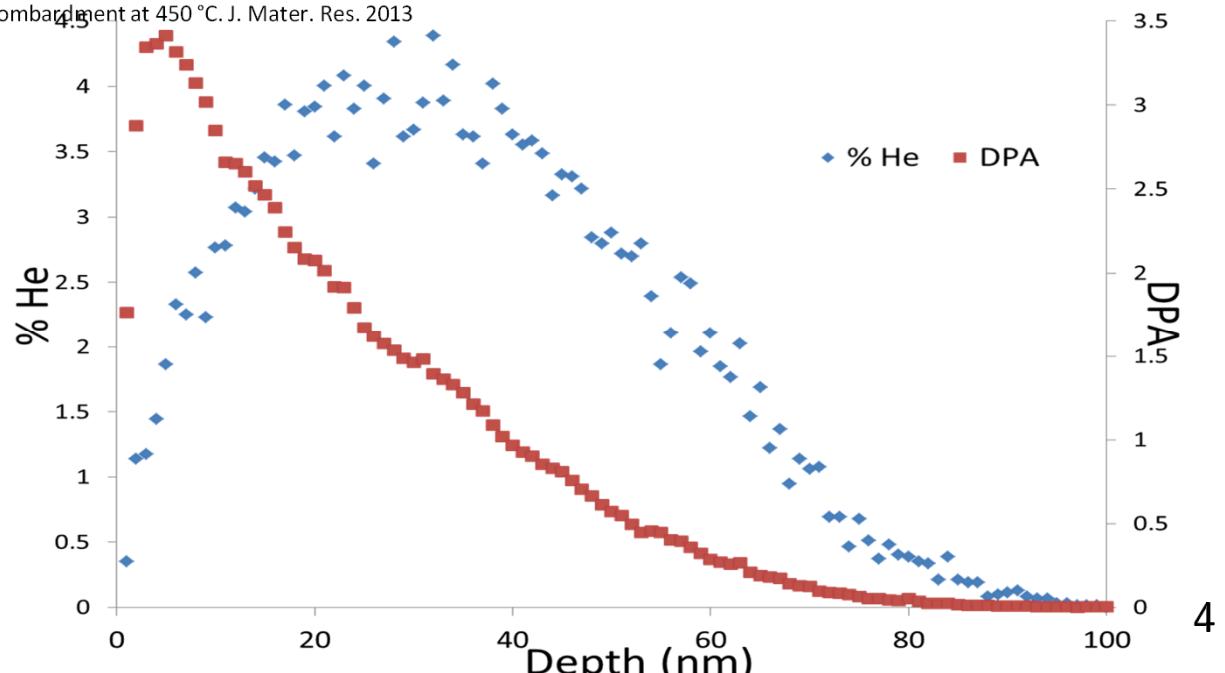


- Defects attracted to interfaces where they can annihilate
- Interfaces may limit cavity growth

10 keV He⁺ into
Nanocrystalline Iron

10^{13} He^{+/cm²s}

2.6×10^{16} He^{+/cm² $\approx 2\%$ He}



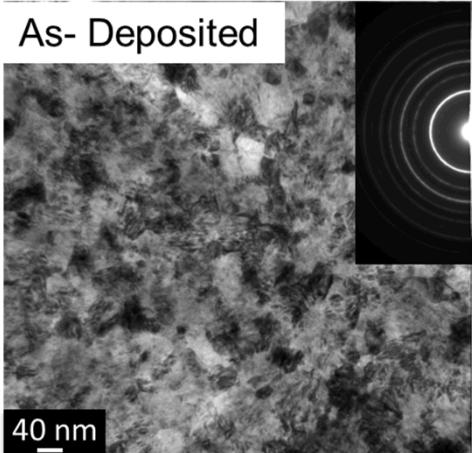
Deposition & Grain Size Tailoring of Iron Films



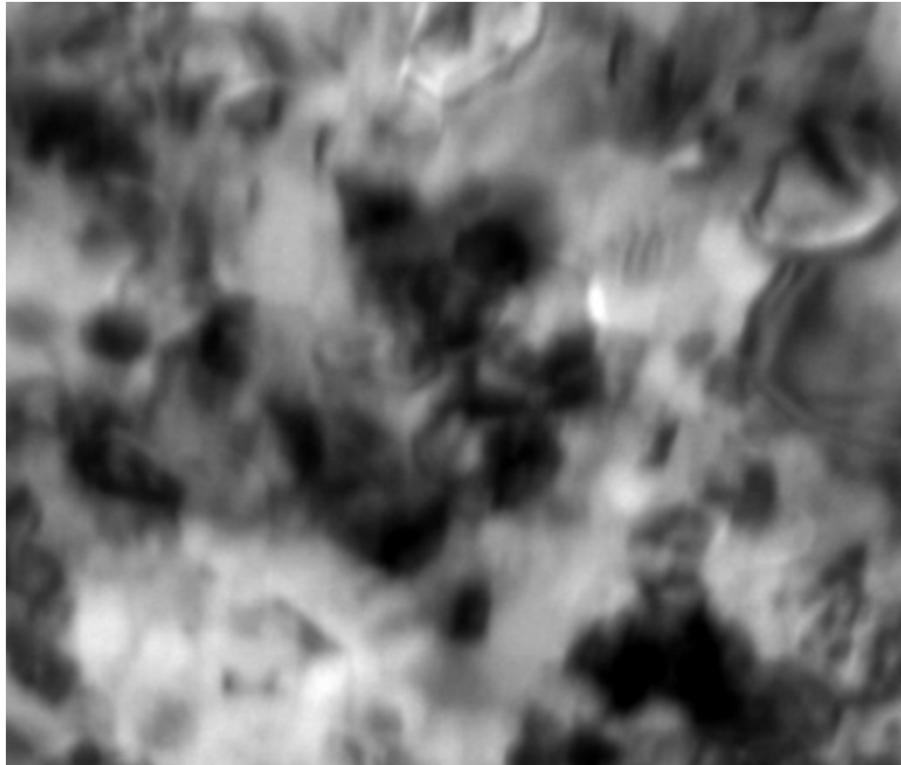
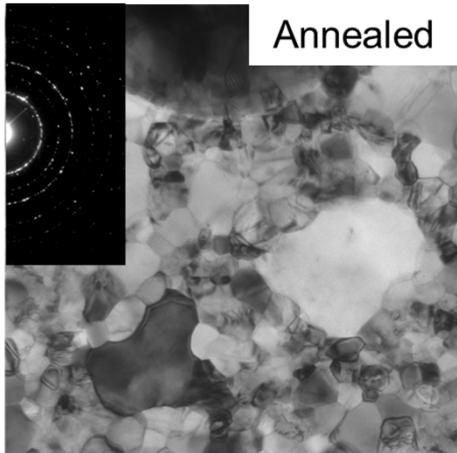
- KrF Excimer laser
 - 35 Hz
 - 4.5×10^{-5} Pa



As- Deposited



Annealed

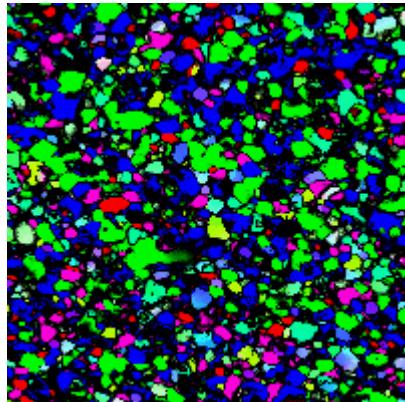
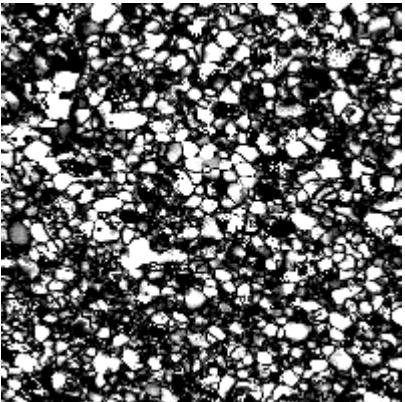
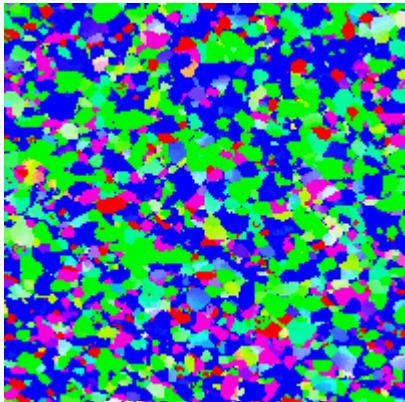


Control grain size within the nanometer regime

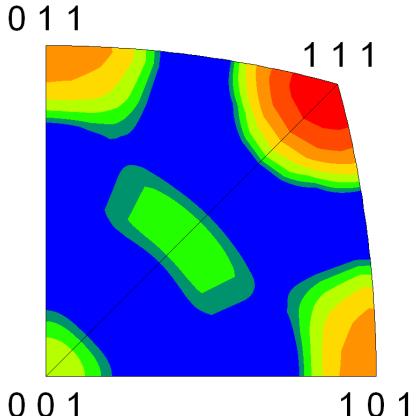
Grain Size and Texture Modification of Iron Films

Annealing results in a stronger texture and loss of (001) oriented grains

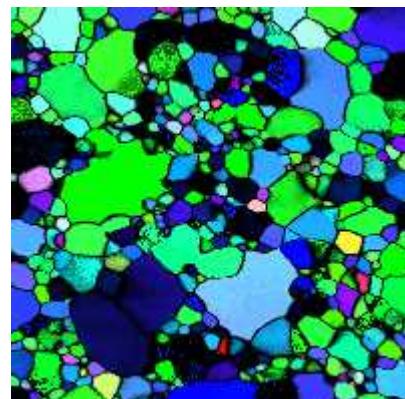
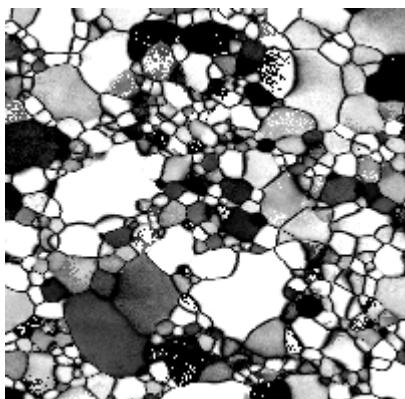
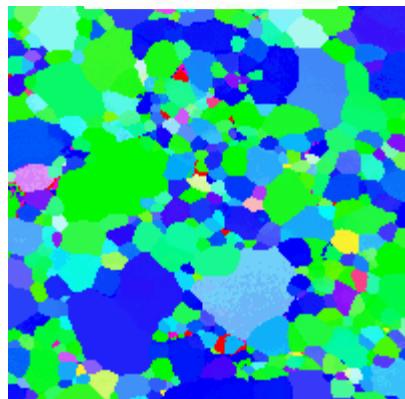
As Deposited



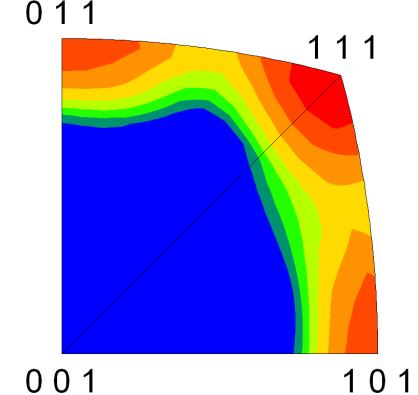
[001]



Annealed



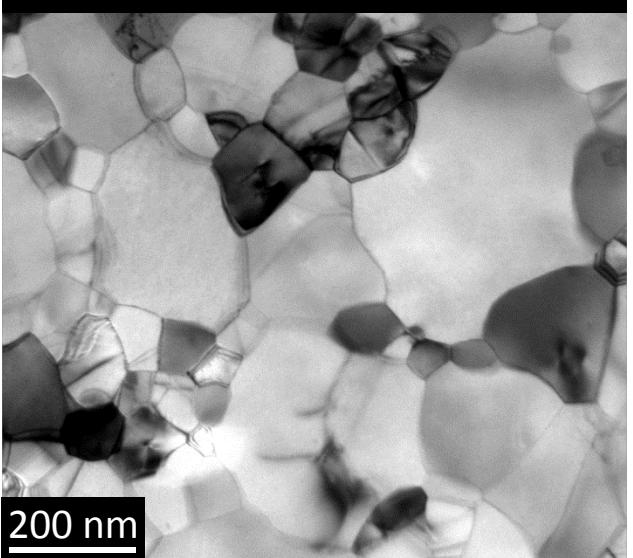
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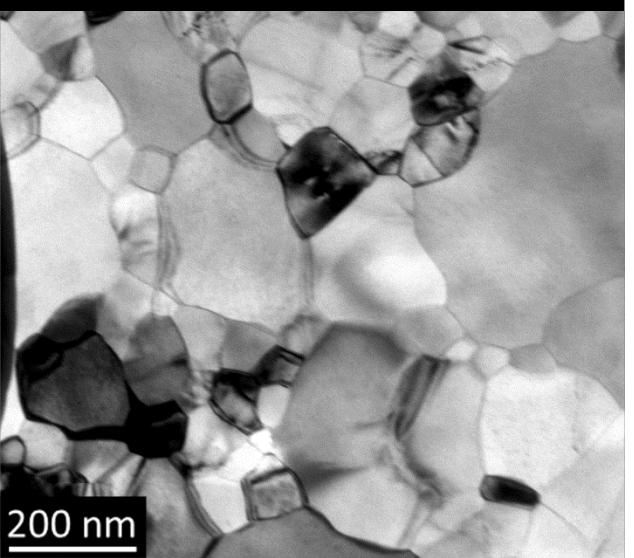
6

Helium Implantation at Room Temperature

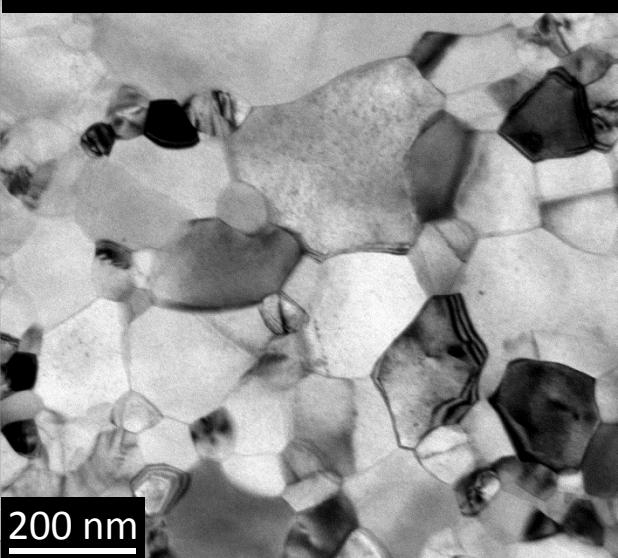
Pre-Implantation



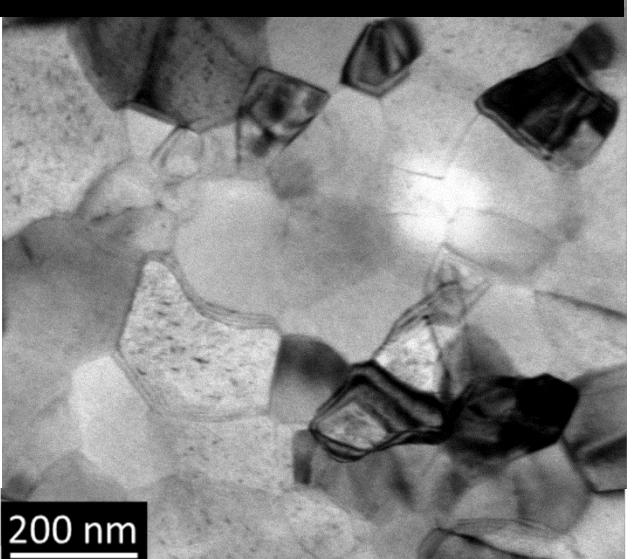
Post-Implantation, 25 °C



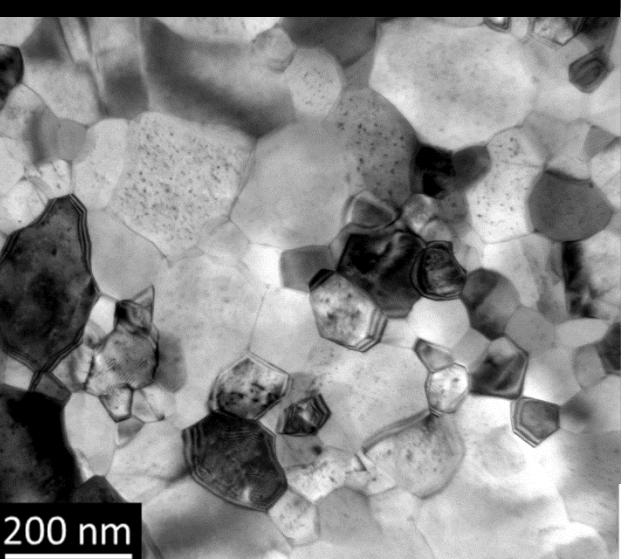
200 °C



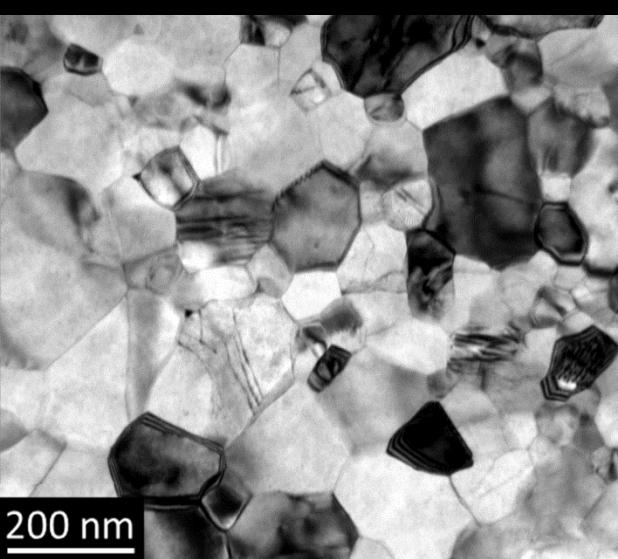
400 °C



500 °C

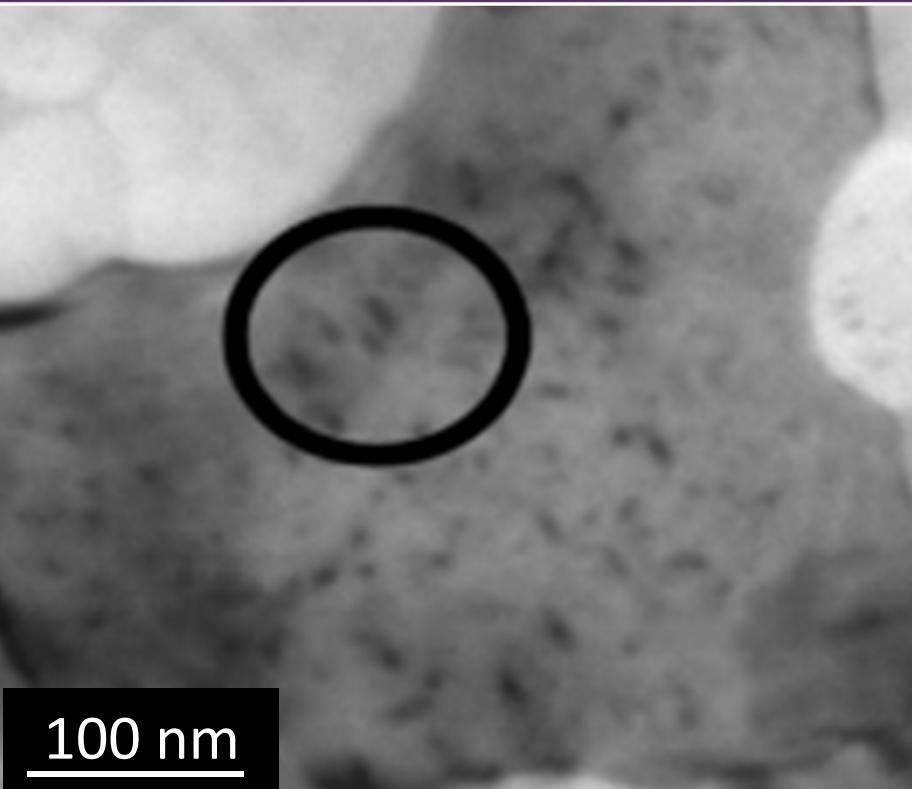


600 °C



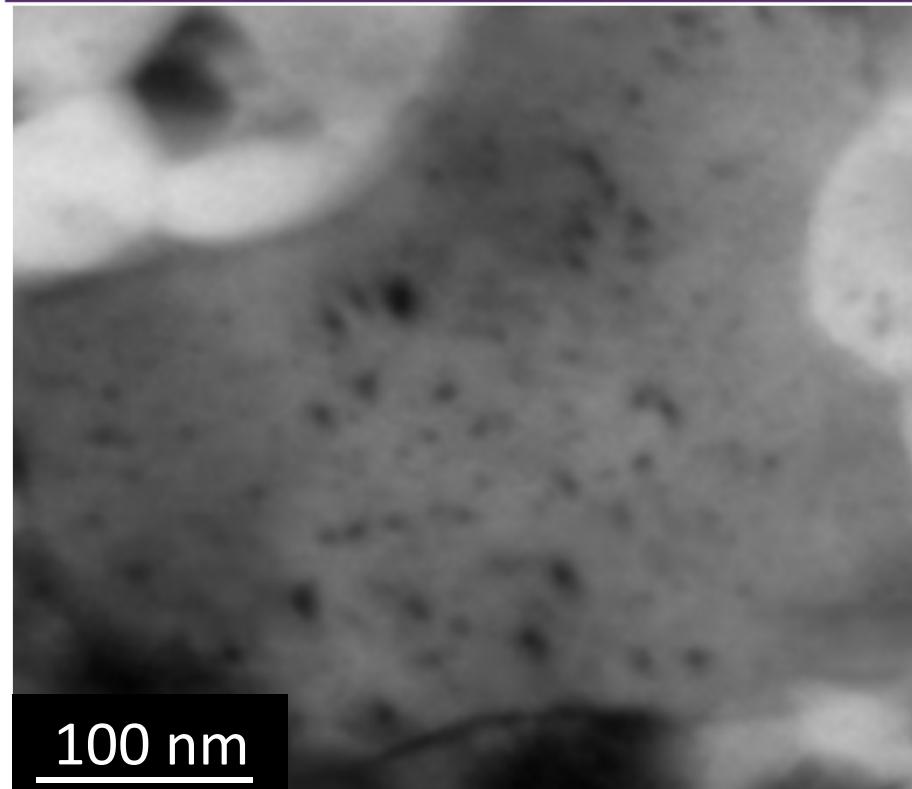
Dislocation Loop Mobility 500 °C to 600°C

Dislocation Loop Coalescence



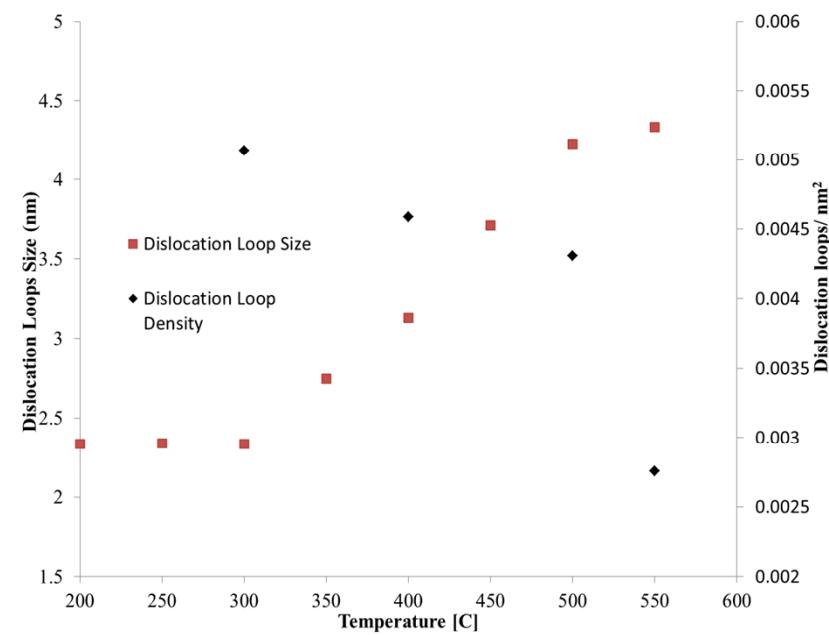
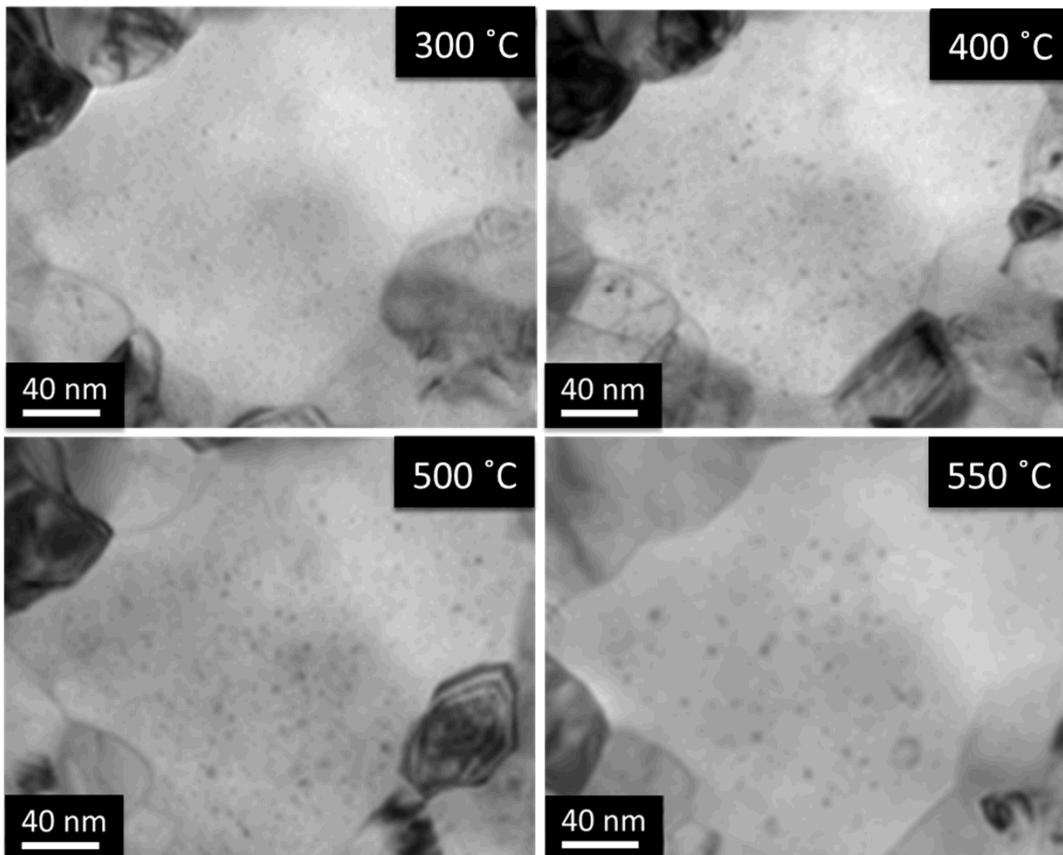
100 nm

Dislocation Loop Migration to Surface



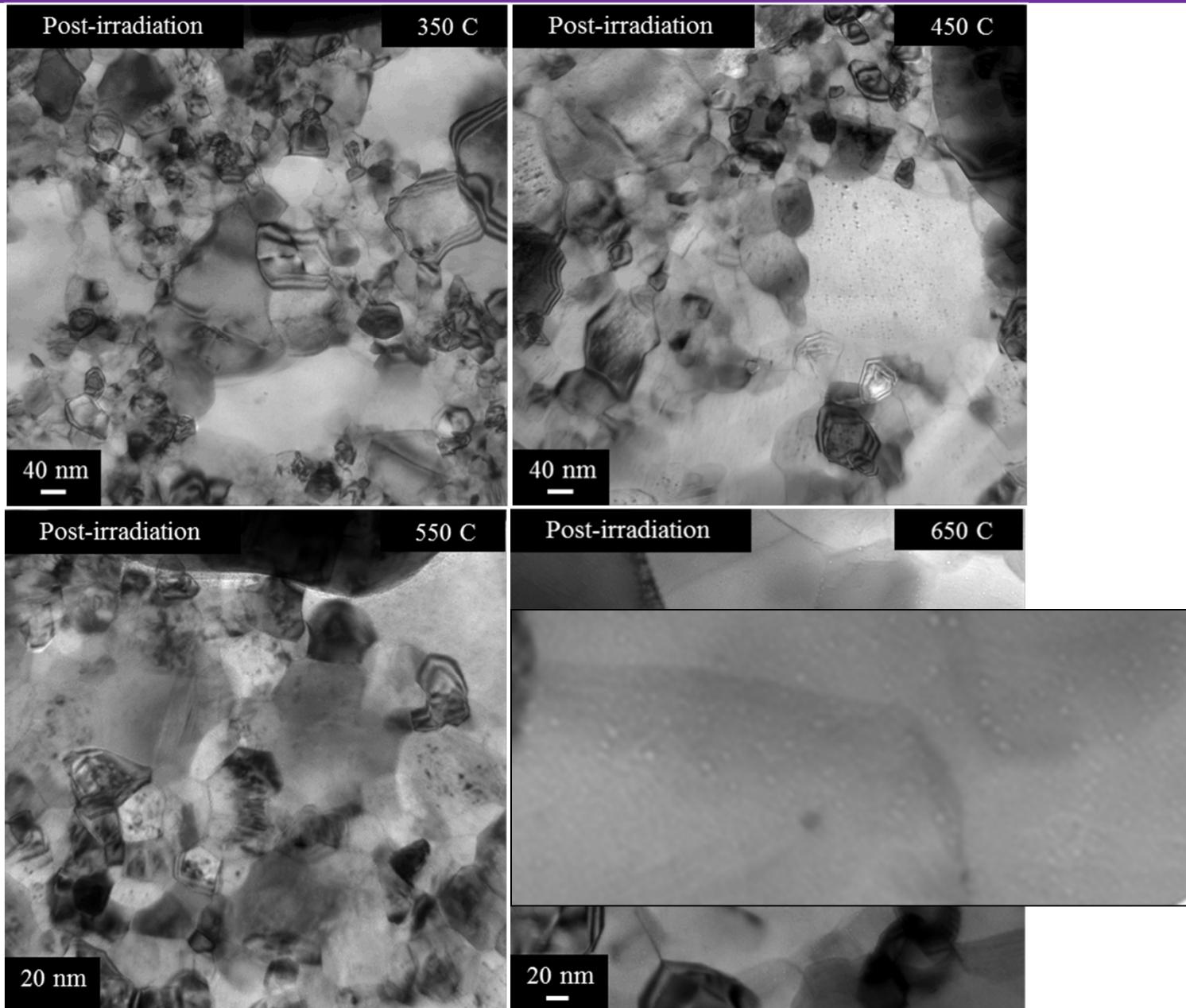
100 nm

Defect Size & Density Evolution with Annealing



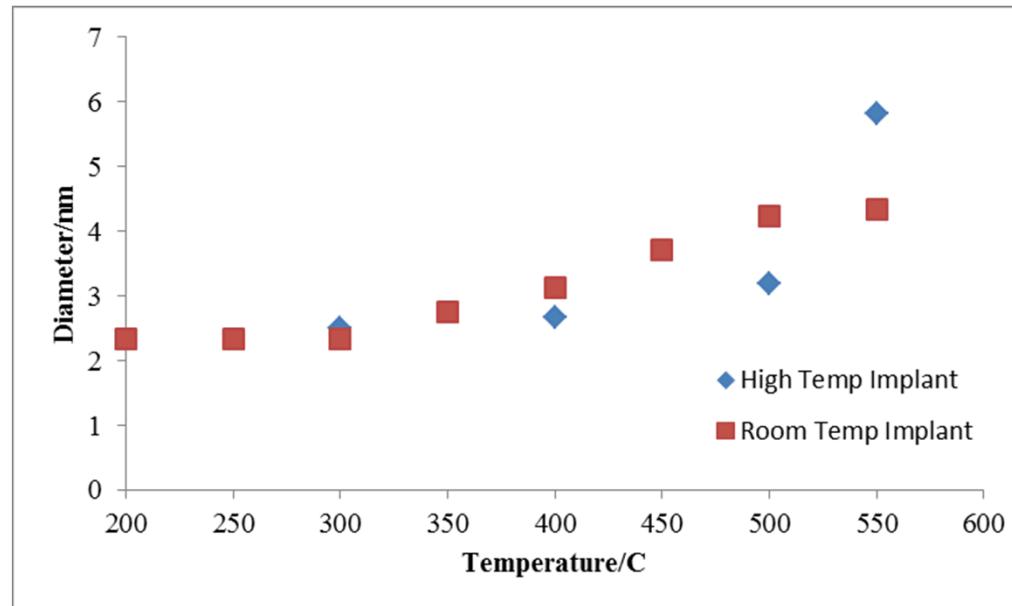
Defect Size Increases, Density Decreases
No visible Cavities

Elevated Temperature Helium Implantation



Summary

- PLD used to create nano-grained Iron films
- Grain size can be controlled
- Annealing results in textured samples
- 10 keV He⁺ implantation at Sandia's I³TEM
- Thermal effects studied
 - Room-temperature implantation then Annealing
 - High temperature implantation
- Similar size defects in both thermal conditions
- Cavities only appear during high-temp implantation



Acknowledgments

US Department of Energy's Nuclear Energy University Program (DE-NE0000678)
Cajer Gong, Daniel Bufford, Dan Buller